

INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.: P-7354	Serial No.: 09/017,190
	Applicant(s): Markus Haller et al.	
	Filing Date: February 2, 1998	Group: 3738

10625 U.S. PAT. 09/519563 03/06/00

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	SubClass	Filing Date If Appropriate
<i>[Signature]</i>	AA	4,866,326	09/12/89	Niikawa et al.	310	315	02/17/88
	AB	4,895,500	01/23/90	Hök et al.	417	566	04/07/89
	AC	5,095,256	03/10/92	Ueyama et al.	318	116	11/29/89
	AD	5,096,388	03/17/92	Weinberg	417	322	03/22/90
	AE	5,147,141	09/15/92	Sakaida et al.	400	124	10/26/89
	AF	5,413,955	05/09/95	Lee et al.	437	86	12/21/93
	AG	5,129,794	07/14/92	Beatty	417	413	08/26/91
	AH	5,171,132	12/15/92	Miyazaki et al.	417	413	12/21/90
	AI	5,224,843	07/06/93	van Lintel	417	413 A	
	AJ	5,259,737	11/09/93	Kamisuki et al.	417	322	07/02/91
<i>[Signature]</i>	AK	5,479,062	12/26/95	Yoshino	310	316	07/29/93

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	SubClass	Translation	
							Yes	No

OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)

<i>[Signature]</i>		"Microflow devices and systems" - S. Shoji and M. Esashi (J. Micromech. Microeng. 4 (1994) pp 157-171)
<i>[Signature]</i>		"Piezo drive circuit performance" - C.M. Lopez (Medtronic)
EXAMINER <i>[Signature]</i>		
Date Considered <i>12/12/03</i>		

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.: P-7354	Serial No.: 09/017,195
	Applicant(s): Markus Haller et al.	
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09/519563**U.S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Name	Class	SubClass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	SubClass	Translation	
							Yes	No
<i>AA</i>	AA	JP 6177449 A	06/24/94	Japan	H01L	41/09		X
	AB	JP 5344755 A	12/24/93	Japan	H02N	02/00		X
	AC	JP 5003683 A	01/08/93	Japan	H02N	02/00		X
	AD	JP 4351200 A	12/04/92	Japan	H04R	17/10		X
	AE	JP 4309273 A	10/30/92	Japan	H01L	41/09		X
	AF	JP 2136245 A	05/24/90	Japan	B41J	02/30		X
	AG	JP 2058280 A	02/27/90	Japan	H01L	41/09		X
	AH	JP 6397854 A	04/28/88	Japan	F02D	41/20		X

OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)

EXAMINER <i>Michael Thompson</i>	Date Considered <i>12/12/03</i>
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*Examiner Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Drawings only